

WHAT IS CLAIMED IS:

1. A substrate cleaning tool for cleaning a substrate, comprising a plurality of thready brush members in a bundle, the brush members having channels formed therein for passage of cleaning liquid.
2. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are capable of ejecting the cleaning liquid through respective surfaces of the brush members.
3. A substrate cleaning tool as claimed in Claim 1, wherein the substrate cleaning tool is capable of rotating against the substrate.
4. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are made of water permeable material and also shaped to be hollow.
5. A substrate cleaning tool as claimed in Claim 2, wherein the brush members have a number of channels for passage of the cleaning liquid.
6. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are formed so as to be water-repellent.
7. A substrate cleaning tool as claimed in Claim 1, wherein the brush members are formed so as to be hydrophilic.
8. A substrate cleaning tool as claimed in Claim 1, wherein the brush members have their respective one ends tied up in a bundle.
9. A substrate cleaning tool as claimed in Claim 8, wherein the brush members extend straihgt.
10. A substrate cleaning tool as claimed in Claim 8,

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11. A substrate cleaning tool as claimed in Claim 1, wherein the brush members have their respective both ends tied up in a bundle and also make loops.

13. A substrate cleaning apparatus comprising:
a substrate cleaning tool having a plurality of thready brush members in a bundle, the brush members having channels formed therein for passage of cleaning liquid;
a scrub arm for holding the substrate cleaning tool;
and
a holder for holding a substrate to be cleaned by the substrate cleaning tool.

15. A substrate cleaning apparatus as claimed in Claim 14, wherein the driving mechanism moves the substrate cleaning tool up and down.

17. A substrate cleaning apparatus as claimed in Claim 14, wherein the driving mechanism moves the substrate cleaning tool up and down and also rotates the substrate cleaning tool.

18. A substrate cleaning apparatus as claimed in Claim 13,

wherein the holder holds the substrate rotatably.

19. A substrate cleaning apparatus as claimed in Claim 13, further comprising a nozzle for ejecting cleaning liquid for rinsing.

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